

**Search Notes**

Application No.

09/842,580

Examiner

Mike Qi

**Applicant(s)**

FUJIEDA, ICHIRO

Art Unit

2871

**SEARCHED**

Class	Subclass	Date	Examiner
349	61	4/6/2004	ZQQ
349	63	4/6/2004	ZQQ
349	113	4/6/2004	ZQQ
349	114	4/6/2004	ZQQ
349	65	4/6/2004	ZQQ
349	62	4/6/2004	ZQQ
362	31	4/6/2004	ZQQ
362	26	4/6/2004	ZQQ

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
East search	4/6/2004	ZQQ
Patentability of claims consulted with Mr. Ken Parker VJ	4/6/2004	ZQQ